L Number	Hits	Search Text	DB	Time stamp
2	2113229	resistance neatemperature	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:00
3	32732	resistance near temperature	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:00
4	532	increasing near temperature near rapidly	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:01
5	65	ceramic and gas adj sensor and (heater or heating adj element) near embedded	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
6	0	(increasing near temperature near rapidly) and (ceramic and gas adj sensor and (heater or heating adj element) near embedded)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
7	14	(resistance near temperature) and (increasing near temperature near rapidly)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
8	0	(ceramic and gas adj sensor and (heater or heating adj element) near embedded) and ((resistance near temperature) and (increasing near temperature near rapidly))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
9	501	ceramic and gas adj sensor and embedded	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
10	0	((resistance near temperature) and (increasing near temperature near rapidly)) and (ceramic and gas adj sensor and embedded)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
11	118478	219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:03
12	122	heating near gas near sensor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:03
13	4	(ceramic and gas adj sensor and heat$ near embedded) and (heating near gas near sensor)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06
15	0	(increasing near temperature near rapidly) and ((ceramic and gas adj sensor and embedded) and 219/$.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06
17	3	((resistance near temperature) and (increasing near temperature near rapidly)) and 219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06

16	25	(increasing near temperature near rapidly) and 219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:08
14	16	(ceramic and gas adj sensor and embedded) and 219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:33
20	2	increasing adj temperature adj heater adj rapidly	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:35
19	2	increasing adj temperature adj heater adj slowly	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:36
18	1	temperature adj substrate near temperature adj heater	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:35
21	72	(resistance near temperature) and (ceramic and gas adj sensor and embedded)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:37
22	4	219/$.ccls. and ((resistance near temperature) and (ceramic and gas adj sensor and embedded))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:38
23	27228	controlling and measuring and resistance and rate and increasing and temperature	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:39
24	0	ceramic and gas adj sensor and heat$ near embedded21 and (controlling and measuring and resistance and rate and increasing and temperature)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:40
25	12	((resistance near temperature) and (ceramic and gas adj sensor and embedded)) and (controlling and measuring and resistance and rate and increasing and temperature)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:45
26	642	219/$.ccls. and (controlling and measuring and resistance and rate and increasing and temperature)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:45
27	1	(ceramic and gas adj sensor and embedded) and (219/$.ccls. and (controlling and measuring and resistance and rate and increasing and temperature))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:45

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5	65	ceramic and gas adj sensor and (heater or heating adj element) near embedded	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
6	0	(increasing near temperature near rapidly) and (ceramic and gas adj sensor and (heater or heating adj element) near embedded)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
7	14	(resistance near temperature) and (increasing near temperature near rapidly)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
8	0	(ceramic and gas adj sensor and (heater or heating adj element) near embedded) and ((resistance near temperature) and (increasing near temperature near rapidly))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
9	501	ceramic and gas adj sensor and embedded	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
10	0	((resistance near temperature) and (increasing near temperature near rapidly)) and (ceramic and gas adj sensor and embedded)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:02
11	118478	219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:03
12	122	heating near gas near sensor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:03
13	4	(ceramic and gas adj sensor and heat$ near embedded) and (heating near gas near sensor)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06
15	0	(increasing near temperature near rapidly) and ((ceramic and gas adj sensor and embedded) and 219/$.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06
17	3	((resistance near temperature) and (increasing near temperature near rapidly)) and 219/$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/19 15:06

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| 16 | 25 | (increasing near temperature near rapidly) and 219/$.ccls. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/08/19 15:08 |
| 14 | 16 | (ceramic and gas adj sensor and embedded) and 219/$.ccls. | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB | 2004/08/19 15:14 |